PROGRAM

August 3, 2009

8:30 AM **Registration**

9:10 AM Conference Opening

Jong-Min Liu (ITRI)

Ta-Jo Liu (National Tsing Hua University)

Session A

Session Chairman: Profs. Carlos Tiu and An-Bang Wan

9:30 AM	New Approach for Coating Processes of Functional Films
	Yukio Yamaguchi (Univ. of Tokyo)
10:00 AM	Break
10:30 AM	Beyond Rheometry in IT Applications
	Kyung Hyun Ahn (Seoul National Univ.)
11:00 AM	Creating Multi-Scale Structures during Drying
	Masato Yamamura (Kyushu Inst, Tech.)
11:30 AM	Coating Industry and Research in Taiwan
	Ta-Jo Liu (National Tsing Hua University)
	Coating Fundamentals Research Community Worldwide
	Shuzo Fuchigami (ISCST Rep.)

12:00 PM **Lunch**

Session B

Session Chairman: Profs. Yoshiyuki Komoda and Masahiro Fujita

13:00 PM	Effect of Coating Process on Structure of Organic Thin Film and its Electric Properties Keisuke Oku (Univ. of Tokyo)
13:20 PM	Film Formation of Flocculated Silica/PVA Suspension Sunhyung Kim (Seoul National Univ.)
13:40 PM	Porous Structures in Phase Separating Coatings under Marangoni Flow Sintaro Eikai (Kyushu Inst. Tech.)
14:00 PM	Drying-induced Birefringence of Polyimide Optical Films Po-Ju Chen (National Tsing Hua Univ.)
14:20 PM	Formation Mechanism of 3D-Morphologies of Colloidal Particles during Drop Drying on Hydrophobic Substrate Yoshihisa Hirano (Univ. of Tokyo
14:40 PM	Break
15:00 PM	Drying Regime Map for Particulate Coating Yoon Dong Jung (Seoul National Univ)
15:20 PM	Star-Cracks on Silica Suspension Film Surface <u>Takakazu Kubota (Kyushu Inst. Tech.)</u>
15:40 PM	The Fluid Mechanics of Stripe Coating Chi-Feng Lin (National Tsing Hua Univ.)
16:00 PM	Evaluation of Drying Process of Slurry Coated Film by a Laser Displacement Sensor Ritsuko Kimura (Kobe Univ.)

16:20 PM Characterization of Pigment Ink System by Dielectric Spectroscopy

Ayoung Lee (Seoul National Univ.)

17:00 PM Banquet (Hotel Royal Hsinchu)

August 4, 2009

Session C

Session Chairman: Profs. Yukio Yamaguchi and Kyung Hyun Ahn

9:00 AM	Solution Casting of Glycerol and Carboxymethylcellulose (CMC)
	solutions
	Carlos Tiu (Monash Univ.)
9:30 AM	Introduction to the New Development of Pattern-Coating Technology
	An-Bang Wang (National Taiwan Univ.)
10:00 AM	Break
10:30 AM	Mesoscale Simulation of Nanoparticles Suspension in Coating-Drying
	Processes by SNAP
	Masahiro Fujita (Univ. of Tokyo)
11:00 AM	Structure Control of PEFC Electrode by Coating and Drying Technology
	Yoshiyuki Komoda (Kobe Univ.)
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11:30 AM	Formation of Optically Anisotropic Silica Colloidal Films by a Simple
	Drop Drying Method
	Susumu Inasawa (Univ, of Tokyo)

12:00 PM **Lunch**

Session D

Session Chairman: Profs. Masato Yamamura and Susumu Inasawa

13:30 PM	Pervaporation for Solvent Purification
	Anhwa Dwan (Achem Tech. Co.)
14:00 PM	Introduce Crown Machinery and Coating Line Equipment
	Huang-I Pei (Crown Machinery)
14:30 PM	Optimized Pre-Metered Die Coating Methods and their Advantages for
	New Coating Applications
	Harald Doell (TSE Troller AG)
15:00 PM	Break
15:30 PM	Coating Head & Oven Selection
	Chung-Yung Lu (JCM)
16:00 PM	Hybrid Materials Used in Coating and Film Casting Application
	Shih-Ming Chen (ITRI)